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Electronic Patent Application Submission  
USPTO Use Only

EFS ID: 63354  
Application ID: 09841800   
Title of Invention: METHOD OF DEPOSITING METAL  
FILM AND METAL DEPOSITION  
CLUSTER TOOL INCLUDING  
SUPERCRITICAL  
DRYING.CLEANING MODULE  
First Named Inventor: Maximilian Biberger  
Domestic/Foreign Application: Domestic Application  
Filing Date: 2001-04-24  
Effective Receipt Date: 2004-06-25  
Submission Type: Information Disclosure  
Statement  
Filing Type:  
Confirmation number: 6810  
Attorney Docket Number: NONE


Total Fees Authorized:

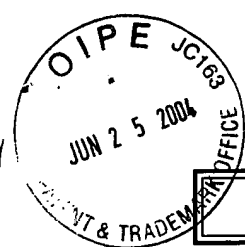
Digital Certificate Holder: cn=Thomas B. Haverstock,ou=Registered Attorneys,ou=Patent and  
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Certificate Message Digest: d64d855841d140b8720b851ff887817bc059c696



TRANSMITTAL

Electronic Version v1.1  
Stylesheet Version v1.1.0

<b>Title of Invention</b>	<b>METHOD OF DEPOSITING METAL FILM AND METAL DEPOSITION CLUSTER TOOL INCLUDING SUPERCRITICAL DRYING.CLEANING MODULE</b>									
<p>Application Number: 09/841800 </p> <p>Date: 2001-04-24</p> <p>First Named Applicant: Maximilian A. Biberger</p> <p>Confirmation Number: 6810</p> <p>Attorney Docket Number:</p>										
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<table border="1"><thead><tr><th>Submitted by:</th><th>Elec. Sign.</th><th>Sign. Capacity</th></tr></thead><tbody><tr><td>Thomas B. Haverstock Registered Number: 32571</td><td>/tbh/</td><td>Attorney</td></tr></tbody></table>			Submitted by:	Elec. Sign.	Sign. Capacity	Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney		
Submitted by:	Elec. Sign.	Sign. Capacity								
Thomas B. Haverstock Registered Number: 32571	/tbh/	Attorney								
<table><tr><td><b>Documents being submitted</b></td><td><b>Files</b></td></tr><tr><td>us-ids</td><td>SSI02001-usidst.xml</td></tr><tr><td></td><td>us-ids.dtd</td></tr><tr><td></td><td>us-ids.xsl</td></tr></table>			<b>Documents being submitted</b>	<b>Files</b>	us-ids	SSI02001-usidst.xml		us-ids.dtd		us-ids.xsl
<b>Documents being submitted</b>	<b>Files</b>									
us-ids	SSI02001-usidst.xml									
	us-ids.dtd									
	us-ids.xsl									
<b>Comments</b>										



## ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of  
Invention

METHOD OF DEPOSITING METAL FILM AND METAL  
DEPOSITION CLUSTER TOOL INCLUDING  
SUPERCRITICAL DRYING.CLEANING MODULE

Application Number: 09/841800



Confirmation Number: 6810

First Named Applicant: Maximilian Biberger

Attorney Docket Number:

Search string: ( 3642020 or 5091207 or 6509141 or  
20030205510 or 20040020518 ).pn.

**Certification:** This Information Disclosure Statement was submitted under the following conditions, which satisfies the requirement under 37 CFR 1.97(e). The filer certified:

That no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in 37 CFR 1.56(c) more than three months prior to the filing of the information disclosure statement.

### US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	3642020	1972-02-15	Payne			
	2	5091207	1992-02-25	Tanaka			
	3	6509141	2003-01-21	Mullee			

### US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass

	1	20030205510	2003-11-06	Jackson	A1
	2	20040020518	2004-02-05	DeYoung et al.	A1

Signature

Examiner Name	Date